INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 21, 2026

IGI Report Number	LG784670645
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.91 - 7.96 X 4.87 MM

GRADING RESULTS

Carat Weight	1.91 CARAT
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

ADDITIONAL GRADING INFORMATION

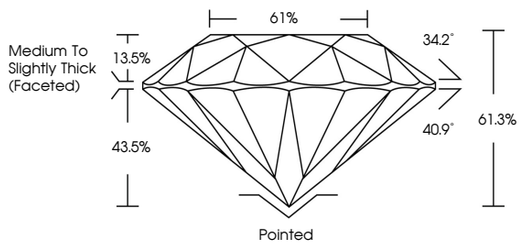
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG784670645

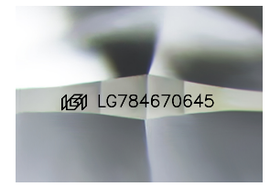
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG784670645

Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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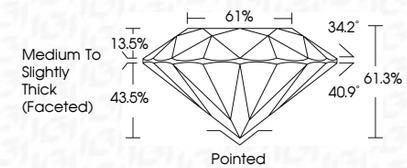

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ROUND BRILLIANT
7.91 - 7.96 X 4.87 MM
Carat Weight 1.91 CARAT
Color Grade E
Clarity Grade VVS 2
Cut Grade EXCELLENT
Depth 61.3%
Table 61%
Girdle Medium To Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG784670645
Comments:
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Type IIa